

**Search Notes**

Application/Control No.

10/589,795

Examiner

Taeyoon Kim

Applicant(s)/Patent under  
Reexamination

HIGA, TERUO

Art Unit

1651

**SEARCHED**

| Class | Subclass | Date | Examiner |
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**INTERFERENCE SEARCHED**

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**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

|  | DATE      | EXMR |
|--|-----------|------|
| EAST search (USPG-pub;USPAT;USOCR;EPO;JPO;Derwent) | 3/20/2009 | TK   |
| Internet search (google; EM, EM-X)                 | 3/20/2009 | TK   |
| Inventor search (PALM)                             | 3/20/2009 | TK   |
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